

κ -Ga₂O₃ thin films and related heterostructures grown by Suboxide-MBE and conventional MBE

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The wide-bandgap semiconductor Ga₂O₃ is considered a promising material for high-power electronic devices, benefiting essentially from its large bandgap and the associated high breakdown field strength. The five polymorphs of Ga₂O₃ also exhibit unique material properties ^[1]. Widely investigated is the thermodynamically stable monoclinic β -Ga₂O₃, from which bulk substrates are commercially available ^[2], and precise n-type doping that enables high carrier mobilities has been established ^[3]. However, the primary focus of this contribution is on the metastable orthorhombic κ -Ga₂O₃. Due to its crystal structure, it is assumed to possess a spontaneous polarization along the c-axis, which makes the realization of high sheet carrier densities at heterointerfaces feasible ^[4].

In this study we focus on two key aspects of κ -Ga₂O₃ growth, the stabilization of the metastable polymorph and the realization of heterostructures. Here, we initially demonstrate the growth of the κ -phase and discuss the phase stabilization and the growth process using suboxide-MBE (S-MBE) as a novel MBE technique and conventional MBE (C-MBE), both combined with the use of the known additive tin ^[5,6]. The growth regimes in which a phase transformation from β -Ga₂O₃ to κ -Ga₂O₃ occurs are identified and characteristics of the obtained layers are compared.

Additionally, we focus on the growth of Ga₂O₃-based heterostructures using both growth techniques (S-MBE and C-MBE). The study examines the combination of different polymorphs in superlattice heterostructures, specifically β -Ga₂O₃/ κ -Ga₂O₃. This provides through scanning transmission electron microscopy insights into the atomic arrangement of both polymorphs at the interfaces. Furthermore, κ -Ga₂O₃/ κ -(Al,In,Ga)₂O₃ heterostructures are studied and the strain state in κ -Ga₂O₃/ κ -InGaO/ κ -AlGaO heterostructures is investigated ^[7], since fully strained structures are promising candidates for the realization of carrier accumulation at heterointerfaces.

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[3] Maccioni et al., Appl. Phys. Express **9**, 041102 (2016)

[4] Kang et al., J. Phys. Condens. Matter **29**, 234001 (2017)

[5] Vogt et al., U.S. Patent No. 11,462,402 (2022)

[6] Karg et al., J. Appl. Phys. **132**, 195304 (2022)

[7] Karg et al., APL Mater. **11**, 091114 (2023)

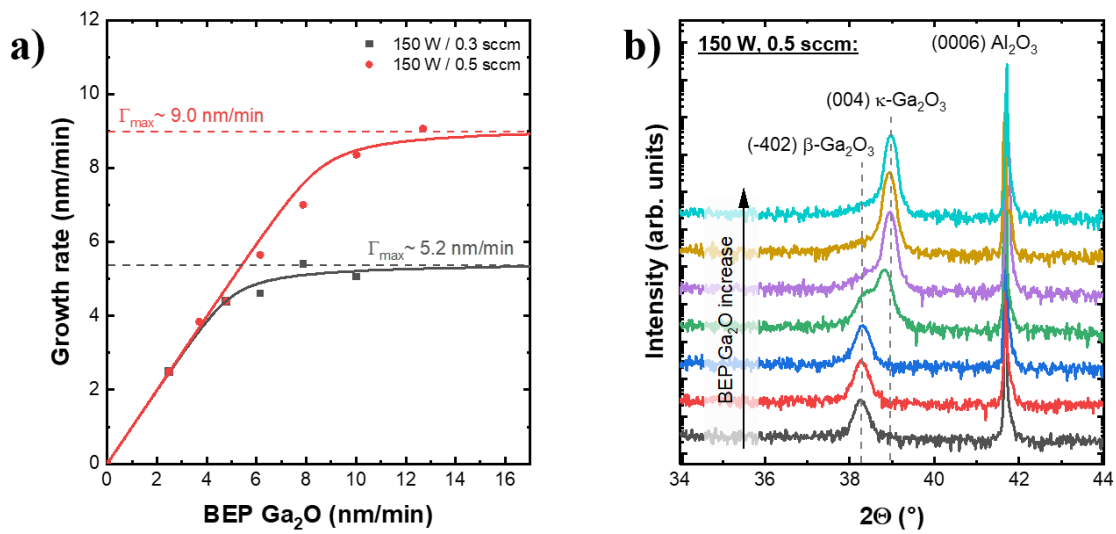


Fig. 1: a) Ga₂O₃ growth rate as a function of gallium suboxide (Ga₂O) flux. For both series grown at different plasma settings, the adsorption-controlled regime with a constant growth rate is reached, indicating the single-step growth mechanism of κ -Ga₂O₃ when using S-MBE. b) XRD spectra of the series grown at 150 W and 0.5 sccm revealing the phase transition from β - to κ -Ga₂O₃ when increasing the Ga₂O flux.

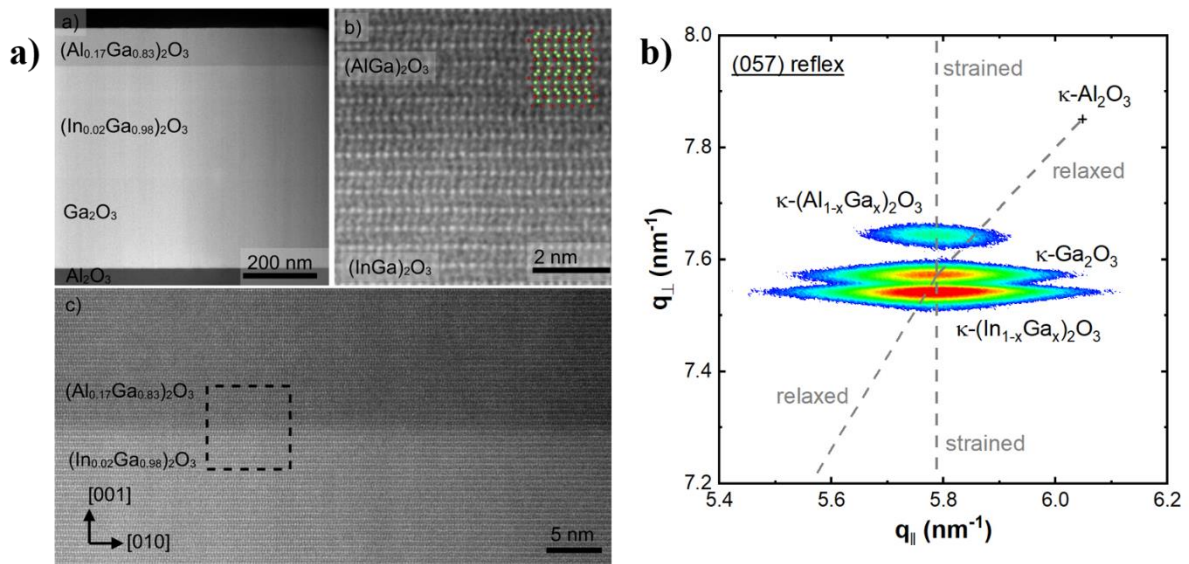


Fig. 1: a) STEM images of a κ -Ga₂O₃/ κ -(In,Ga)₂O₃/ κ -(Al,Ga)₂O₃ heterostructure, showing a sharp distinct transition between the κ -(In,Ga)₂O₃ and κ -(Al,Ga)₂O₃ layer. b) The corresponding reciprocal space map of the heterostructure displayed in a) indicates the pseudomorphic growth throughout the layer sequence [7].